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From: Mark C. Pickering
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Examination
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF
 Inventors: Heikyung Min et al.

Appln. No.: 10 | 032,930
 Series Code ↑ Serial No. ↑

Filed: October 29, 2001

Title: APPARATUS AND METHOD FOR REDUCING SURFACE ZENER DRIFT USING TI-BASED METALLURGY

Date: February 20, 2002

Commissioner for Patents
 Washington, D.C. 20231
 Attn.: Office of Initial Patent Examination

Sir:

REQUEST FOR CORRECTED FILING RECEIPT

- Attached is a copy of the official filing receipt from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.
- There is an error with respect to the following data which is

☒ incorrectly entered

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Error in

Correct data

1. ☒ Third Applicant's First Name

2. Robert Spence

Please see the attached copy of Declaration as filed.

- It is understood that the PTO no longer charges for correcting filing receipts even when the error is applicants' mistake, but if that is incorrect and a fee is due for this correction please charge our Deposit Account No. 03-3975 under Order No. 072219-0278259

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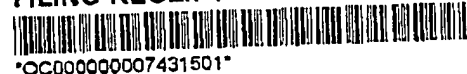
APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/032,930	10/29/2001	2811	740	072219- 0278259 (P05108)	7	20	2

CONFIRMATION NO. 8013

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FILING RECEIPT



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Date Mailed: 02/06/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

 Heikyung Min, Palo Alto, CA;
 Steven Kurihara, San Jose, CA;
~~Bob~~ Spence, Skelmorlie, UNITED KINGDOM;
ROBERT

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 02/06/2002

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

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Title

Apparatus and method for reducing surface zener drift using Ti-based metallurgy

Preliminary Class

257

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